

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent of : Attorney Docket No. 2004_0347A
Toshiyuki TAKIZAWA :
Patent No. 7,786,550 :
Issued August 31, 2010 :
P-TYPE SEMICONDUCTOR AND :
SEMICONDUCTOR HETERO MATERIAL
AND MANUFACTURING METHODS
THEREOF

SUBMISSION OF SUPPLEMENTAL DECLARATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present supplemental Declaration is submitted to correct a number of typographical errors that were inadvertently included in the executed Declaration filed March 3, 2004. These errors occurred without deceptive intent. The supplemental Declaration changes the city of residence of the inventor from "Osaka-shi" to "Kyoto" and changes the post office address from "4-22, Kaida, Nagaokakyo, Kyoto, Japan 617-0826" to "4-22, Kaiden, Nagaokakyo, Kyoto, Japan 617-0826".

Accordingly, it is requested that the attached Supplemental Declaration be placed in the application file.

Respectfully submitted,

Toshiyuki TAKIZAWA

/David M. Ovedovitz/

By 2010.12.13 14:17:04 -05'00'

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